



17W
PATENT
790001-2034

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Noriaki Matsunaga et al.
Serial No. : 10/628,689
Filed : July 28, 2003
For : ***SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD***
Examiner : Hoai V. Pham
Art Unit : 2814

745 Fifth Avenue
New York, NY 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 28, 2004.

Bruno Polito, Reg. No. 38,580

(Name of Applicant, Assignee or Registered Representative)

Signature

June 28, 2004

Date of Signature

RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed May 26, 2004, setting a one-month period for reply and asserting a restriction requirement, Applicants request reconsideration and withdrawal of the restriction requirement in view of the following remarks. Further, Applicants submit the following claim amendments.